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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NIHEI, Mizuhisa, et al.

Serial No.: **10/796,146**

Filed: **March 10, 2004**

Group Art Unit: **2813**

Examiner: **Thanhha Pham**

P.T.O. Confirmation No.: **2043**

For: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF**

RESPONSE UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Please do not enter.
/Thanhha Pham/
12/23/2008

December 1, 2008

Sir:

In response to the Office Action dated July 29, 2008, extended from October 29, 2008 to December 1, 2008 (November 29, 2008 being a Saturday) by a **one**-month Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page **two** of this paper.

Remarks/Arguments begin on page **nine** of this paper.